



This is to certify that the Quality Management System of

MEMSIC Semiconductor (Wuxi) Co., Ltd.

Areas ACEF of Plant 1, Plant 2 and R&D Building, No. 2 Xinhuihuan Road, Xinwu District, Wuxi City, Jiangsu Province, 214028, China.

applicable to

The design and manufacture of heat convection MEMS acceleration sensors

has been assessed and registered by

NQA, Warwick House, Houghton Hall Park, Houghton Regis, Dunstable LU5 5ZX, Bedfordshire, England

against the provisions of

IATF 16949:2016

This registration is subject to the company maintaining a quality management system, to the above standard, which will be monitored by NQA

Managing Director



NQA Certificate No:	T11564
IATF Certificate No:	0435699
Date:	25 November 2021
Valid Until:	24 November 2024
Version:	1



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